



**ELECTRONIC COPY**

LG735562480  
Report verification at igi.org



September 22, 2025  
IGI Report Number **LG735562480**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **EMERALD CUT**  
Measurements **7.91 X 5.18 X 3.33 MM**

**GRADING RESULTS**

Carat Weight **1.50 CARAT**  
Color Grade **E**  
Clarity Grade **VS 1**

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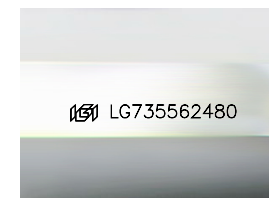
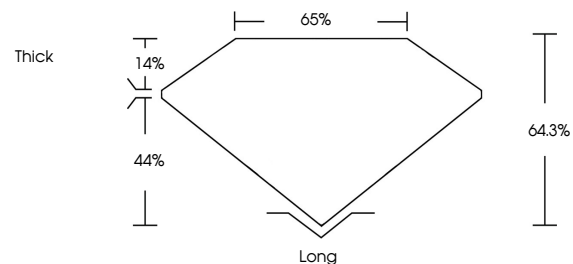
Carat Weight **1.50 CARAT**  
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**ADDITIONAL GRADING INFORMATION**

Polish **VERY GOOD**  
Symmetry **VERY GOOD**  
Fluorescence **NONE**  
Inscription(s) **IGI LG735562480**

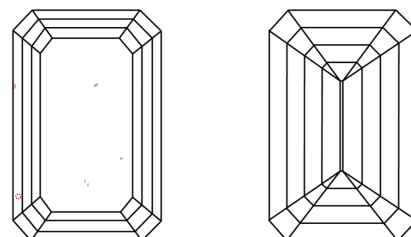
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

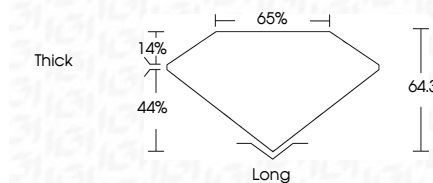
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**

September 22, 2025  
IGI Report No LG735562480  
**EMERALD CUT**  
1.50 CARAT  
E  
7.91 X 5.18 X 3.33 MM  
Carat Weight  
Color Grade  
Clarity Grade  
Depth  
Table  
Girdle  
Thick  
Long  
Culet  
Polish  
Symmetry  
Fluorescence  
Inscription(s)  
**VERY GOOD**  
**VERY GOOD**  
**NONE**  
**IGI LG735562480**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

